



IN THE UNITED STATES
PATENT AND TRADEMARK OFFICE

PATENT APPLICATION

Peter Ledel Gammel
Richard Edwin Howard
Omar Daniel Lopez
Wei Zhu

CASE 18-47-1-57

Serial No. 09/651696 Group Art Unit 2879

Filed August 30, 2000

Examiner T. Lee

Title On-Chip Vacuum Tube Device And Process For Making Device

ASSISTANT COMMISSIONER FOR PATENTS

WASHINGTON, D. C. 20231

SIR:

INFORMATION DISCLOSURE STATEMENT
CERTIFICATION UNDER 37 CFR 1.97(e)(1)

In accordance with 37 CFR 1.97(e)(1), the enclosed Information Disclosure Statement, with attached reference(s), is submitted for consideration in the above-identified application.

I certify that each item of information contained in the Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement. Copies of the listed documents are enclosed together with the search report that listed these documents.

NO FEE IS REQUIRED

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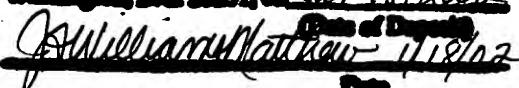
Respectfully,

Scott J. Rittman, Attorney
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Date: Jan 18, 2002

Agere Systems Inc.
P.O. Box 614
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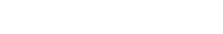
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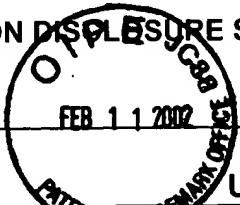

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INFORMATION DISPLEASURE STATEMENT 	Case Name: Serial No. Applicant: Filing Date: Group:	P.L. Gammel 18-47-1-57 09/651696 P.L. Gammel, et al. August 30, 2000 2879
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U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation
	AG	EP0880077A2	5/5/98	Europe	G03F	9/00	
	AH	WO98/44529	10/8/98	International	H01J	9/02	

OTHER (including Author, Title, Date, Pertinent Pages, etc.)

	AI	Iannazzo, S., "A Survey Of The Present Status Of Vacuum Microelectronics", Solid-State Electronics, Vol. 36, No. 3, pages 301-320, March 1, 1993.

***References listed beyond AZ would list as AA-1, AB-2, AC-3 thru AZ-26.

***Note First Page ONLY Header/Footer. Subsequent pages must ONLY have page # layout as header

EXAMINER	DATE CONSIDERED
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***Examiner:** Initial if reference considered, whether or not citation is in conformance with MPEP 609: Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant